



03500.011922.3

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MITSUTOSHI HASEGAWA

Application No.: 09/966,595

Filed: October 1, 2001

For: METHOD OF MANUFACTURING
ELECTRON-EMITTING DEVICE,
ELECTRON SOURCE AND IMAGE-
FORMING APPARATUS

Examiner: M. Cleveland

Group Art Unit: 1762

March 11, 2002

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Mits
3/28/02

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Commissioner For Patents
Washington, D.C. 20231

AMENDMENT

Sir:

This paper is filed in response to the Office Action of December 10, 2001 (Paper No. 5), which set forth a shortened statutory period for reply ending on Sunday, March 10, 2002.

In response to that Office Action, please amend the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on March 11, 2002.

(Date of Deposit)

FRANK A. DeLUCIA

(Name of Attorney for Applicant)

March 11, 2002

Date of Signature

Signature